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500.41301CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): M. ARAI, et al
Serial No.: 10/670,288
Filed: September 26, 2003
For: PLASMA PROCESSING APPARATUS
Group: 2821
Examiner: T. Dinh

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 12, 2004

Sir:

In response to the Office Action dated April 20, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification;

Amendment of the Claims;

Remarks are included following the amendments; and

A Terminal Disclaimer accompanies this Amendment.